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PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

INVENTOR: C. P. Ausschnitt )  
SERIAL NO.: 10/771,684 )  
FILING DATE: February 3, 2004 ) DATE: January 24, 2006  
FOR: METHOD OF PATTERNING PROCESS METROLOGY BASED ON  
THE INTRINSIC FOCUS OFFSET

**CHANGE OF CORRESPONDENCE ADDRESS FOR ALL PURPOSES**

Mail Stop ISSUE FEE  
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Dear Sir:

Pursuant to 37 CFR §1.33, please change the correspondence address, (Customer No. 32074), for all purposes for the above identified patent application and resulting patent to:

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Respectfully submitted,

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